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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Masatoshi FUKUDA et al.**

Group Art Unit: 2815

Serial No.: 10/020,951

Examiner: **Matthew C. Landau**

Filed: **December 19, 2001**

Confirmation No.: 8648

For: **SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING  
THE SAME**

Attorney Docket Number: 011724

Customer Number: 38834

OK to enter  
M.C.L.  
1/5/05

**AMENDMENT UNDER 37 CFR § 1.116**

**BOX: AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

December 15, 2004

Sir:

In response to the Office Action dated September 16, 2004, Applicants amend the above-identified application as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.